

Applicant(s): David Whitney et al.

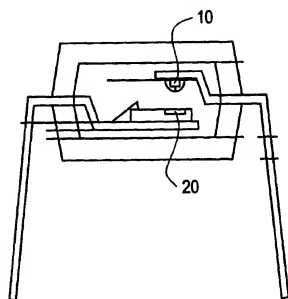
ELECTRICALLY-CONDUCTIVE GRID SHIELD FOR
SEMICONDUCTORS

FIG. 1

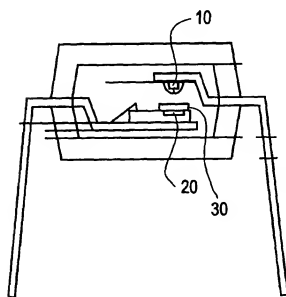


FIG. 2

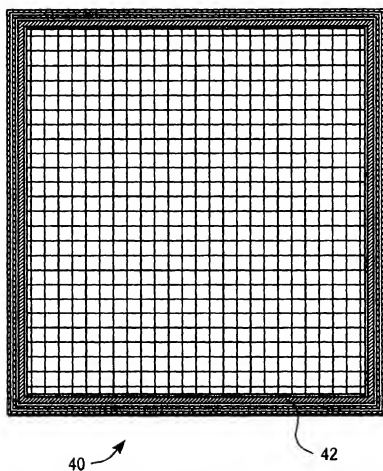


FIG. 3

FIG._4

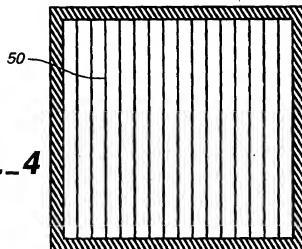


FIG._5

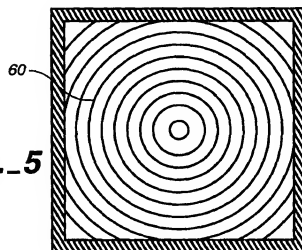


FIG._6

